L M N OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.) Tanabe: "Reactive Ion Etching of AL Alloy Films in a Rotating Magnetic Field", Jpn. J. Appl. Phys., Vol. 32, Part 1, No. 2, dated February 1993, pp. 747-752; Dbe-**EXAMINER** EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw RECEIVED OCT 2 4 2001 TC 1700 line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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